

**METHOD FOR MANUFACTURING MAGNETIC RECORDING MEDIUM AND
METHOD FOR MANUFACTURING LAMINATED BODY**

ABSTRACT

[PROBLEMS] To have a thin film suitably function even when the thickness of the thin film is reduced. [MEANS FOR SOLVING PROBLEMS] Provided is a method for manufacturing a magnetic recording medium by forming a thin film on a substrate (12). The method is provided with a thin film forming step of forming the thin film by using a substance brought into the plasma state as a material. In the thin film forming step, the thin film is formed by using a material substance gathering means (30) for gathering the substance brought into the plasma state to the periphery of the substrate. The material substance gathering means (30) gathers the substance brought into the plasma state, for instance, to the periphery of the substrate (12) by generating a magnetic field at the periphery of the substrate (12).

Fig. 3